



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

July 24, 2026

IGI Report Number

LG821637375

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

MODIFIED MARQUISE STEP CUT

Measurements

11.64 X 5.57 X 3.45 MM

GRADING RESULTS

Carat Weight

1.54 CARAT

Color Grade

E

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG821637375

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

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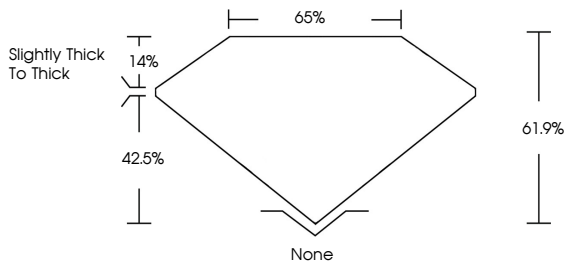
NONE

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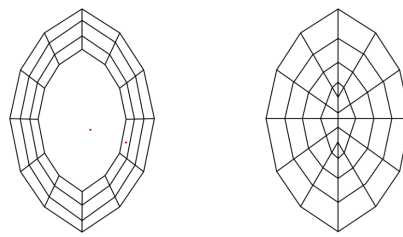
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PROPORTIONS



Slightly Thick To Thick

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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IGI

July 24, 2026

IGI Report No LG821637375

MODIFIED MARQUISE STEP CUT

11.64 X 5.57 X 3.45 MM

Carat Weight

1.54 CARAT

Color Grade

E

Clarity Grade

VVS 2

Depth

61.9%

Table

65%

Graile

Slightly Thick To Thick

Culet

None

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

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